

NOVEMBER 12 2019 | THE STAR IN FRISCO

# AGENDA

9:15 - 9:30	WELCOME & REGISTRATION	
9:30 - 9:45	<b>Introduction</b>	Paul Davies
9:45 - 10:15	<b>INP LASER MANUFACTURING: Ensuring the facet is smooth and vertical</b>	Dr Ligang Deng
10:15 - 10:30	COFFEE	
10:30 - 11:00	<b>VCSEL DEVICE MANUFACTURING: Low footing process for maximum device performance</b>	Stephanie Baclet
11:00 - 11:30	<b>ATOMIC LAYER ETCHING: A new technique for ultra precise and low damage etching</b>	Dr Mark Dineen
11:30 - 12:30	<b>MEET THE EXPERTS: Ask us anything! 1:1 breakout sessions</b>	
12:30 - 13:00	LUNCH BREAK	
13:00 - 13:30	STADIUM TOUR	
13:30 - 14:00	<b>ALD FOR GaN RF DEVICES: Introducing Atomfab, fast plasma enhanced ALD enabling improved interfaces, high quality films and high throughput</b>	Dr Aileen O'Mahony
14:00 - 14:30	<b>SiC POWER DEVICES: Achieving smooth, low defect density substrates and optimum UMOSFET trenches by plasma etching</b>	Dr Mark Dineen
14:30 - 14:45	COFFEE BREAK	
14:45 - 15:45	<b>MEET THE EXPERTS: Ask us anything! 1:1 breakout sessions</b>	

